

TOSHIYOSHI LAB.

Micromachines by Semiconductor Microfabrication

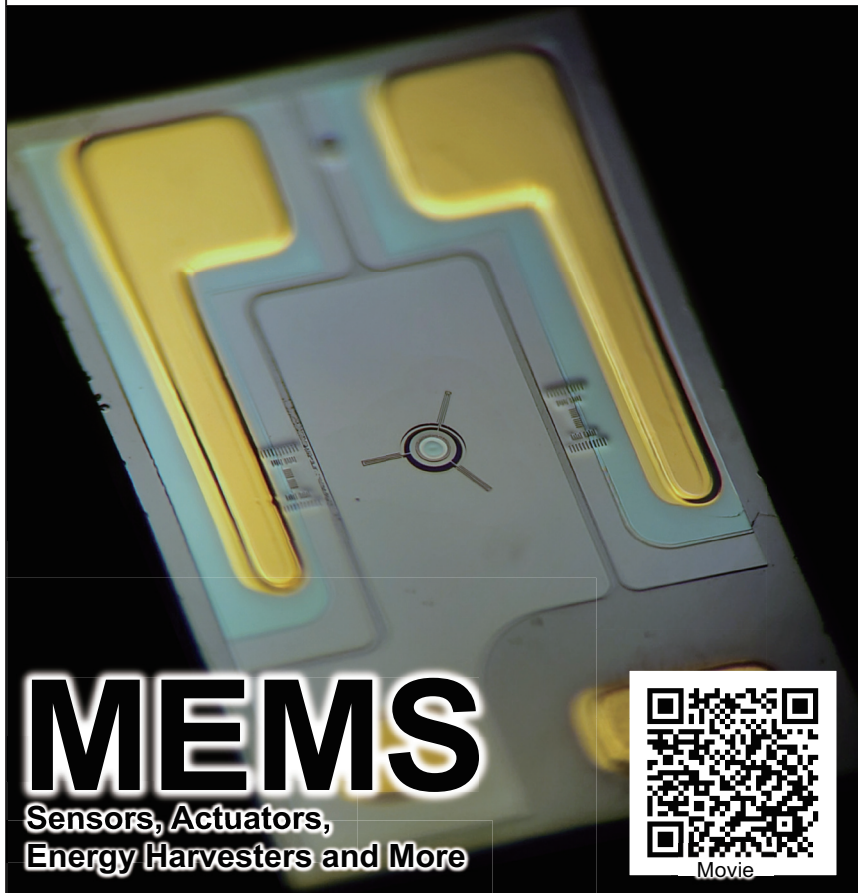


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Centre for Interdisciplinary Research on Micro-Nano Methods

Department of Electrical Engineering and
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Micromachine System Engineering

<http://toshi.iis.u-tokyo.ac.jp/toshilab/>



MEMS

Sensors, Actuators,
Energy Harvesters and More



Movie

